

Synthesis of Passive Lossless Metasurfaces Using Auxiliary Fields for Reflectionless Beam Splitting and Perfect Reflection

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We introduce a paradigm for accurate design of metasurfaces for intricate beam manipulation, implementing functionalities previously considered impossible to achieve with passive lossless elements. The key concept involves self-generation of auxiliary evanescent fields which facilitate the required local power conservation, without interfering with the device performance in the far field. We demonstrate our scheme by presenting exact reactive solutions to the challenging problems of reflectionless beam splitting and perfect reflection, verified via full wave simulations.

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Thin planar arrangements of polarizable subwavelength particles (metasurfaces) have been attracting significant attention lately due to their demonstrated ability to efficiently implement a variety of electromagnetic functionalities [1–5]. Many innovative low-profile devices manipulating the phase, magnitude, and polarization of aperture fields have been reported in recent years [6–17], pointing out the immense potential of these surfaces in optics and microwave physics and engineering.

While the first demonstrations used a single layer of electrically polarizable particles (meta-atoms) [6], it was soon found that these suffer from a limited transmission efficiency. To achieve a unity transmission magnitude with arbitrary transmission phase, both electrically and magnetically polarizable meta-atoms must be used [8,9,18]. When illuminated by an incident field, such metasurfaces induce orthogonal electric and (equivalent) magnetic currents on the surface, forming Huygens' sources, capable of unidirectional radiation [9]. This idea of Huygens' metasurfaces (HMSs) inspired a large number of reports, where such unit cells were arranged to achieve full transmission with a given phase profile, yielding a variety of beam manipulating devices [5].

Nevertheless, it was recently recognized that this common phase-stipulation design scheme is not accurate [4,5]. Maxwell's equations imply that any modification of the phase profile on an aperture should be accompanied by a suitable change in the field amplitudes, due to the inevitable variation of the wave impedance [19]. Thus, stipulating transmitted fields with uniform (unity) amplitude and arbitrary phase is not valid.

This recognition has dramatic implications. For instance, when the boundary conditions corresponding to passive lossless HMSs are rigorously examined, it turns out that plane-wave refraction cannot in general be realized with zero reflection, as the metasurface *symmetric* structure can only be matched to a single wave impedance value

[7,19,20]. This raised the question, could passive lossless metasurfaces achieve truly reflectionless engineered refraction?

A recent paper provided a positive answer to that question [21]. Relying on generalized scattering matrix theory, the authors showed that an *asymmetric* stacking of three reactance sheets could simultaneously match the wave impedance of both the incident and refracted plane waves, leading to zero reflections even in the case of wide-angle refraction. This approach was generalized in [22], showing that this structure corresponds to an omega-type bianisotropic metasurface (O-BMS). In O-BMSs, meta-atoms exhibit electric and magnetic polarizabilities as in HMSs but also feature magnetoelectric coupling [2,23]. This additional degree of freedom allows passive lossless implementation of metasurfaces which are matched to different wave impedances on their top and bottom facets [24].

The wave impedance perspective, thus, can be used to find a realizable solution for transforming a given incident plane wave to a desirable transmitted plane wave. But what happens when more than one mode exists below or above the metasurface? When the incident plane wave is to be split into two transmitted beams, or reflected in a different direction, the interference between the modes does not allow a proper definition of two distinctive network ports for the top and bottom metasurface facets; this prevents utilization of microwave network theory as in [21]. In fact, these fundamental diffraction engineering problems have very recently been examined by several authors, which either concluded that inclusion of lossy or active meta-atoms is required for the implementation, or suggested an approximate approach which does not form a valid solution to Maxwell's equations [4,25,26]. In [26], the authors described some general ideas for potential lossless solutions; nonetheless, it was implied therein that these would require exotic elements, exhibiting nonreciprocity or

nonlocality, whose passive implementation prospects are unclear. To the best of our knowledge, whether or not an accurate design of passive lossless metasurfaces for such applications is possible remains an open question.

In this Letter, we propose a different paradigm to tackle these problems. The solution relies on the theorem proved in [22], indicating that *any* field transformation that *locally* conserves the real power can be implemented by passive lossless O-BMSs. Designing a reflectionless refracting metasurface thus becomes trivial, as both the incident and transmitted plane waves feature uniform power profiles, easily matched by proper stipulation of the field amplitudes [21,22] (this result was independently derived in [26]). On the other hand, trying to apply this theorem naively for the cases of beam splitting or engineered reflection will fail, as the incident and diffracted fields form nontrivial spatially varying power profiles, which do not match, in general.

Hence, the key concept underlying our solution is the use of auxiliary fields to achieve local power conservation. This approach dictates a judicious stipulation of evanescent field components, additional to the prescribed excitation and desirable scattered fields, such that the interference between all modes guarantees the continuity of the real power at each point on the metasurface plane, without affecting the overall device functionality in the far field. The electromagnetic fields analytically stipulated by this scheme form an *exact* solution to Maxwell's equations, supported by a suitable passive and lossless O-BMS design.

To demonstrate the versatility of our concept, we present solutions to these two basic diffraction engineering problems (beam splitting and perfect reflection), featuring qualitatively different power profiles, verified via a commercially available finite-element solver (ANSYS HFSS) [21,22]. The simulated meta-atom structures correspond to typical printed-circuit-board-compatible metasurface designs [3,27], as detailed in [28]. It should be stressed that the physical rationale explored herein is general, and can be applied to a wide range of metasurface problems. The applications addressed in the paper were chosen to emphasize the conceptual leap required to implement challenging functionalities via passive lossless metasurfaces, deliberately introducing auxiliary fields to facilitate the solution.

For simplicity, we consider a two-dimensional configuration ($\partial/\partial x = 0$) with transverse electric (TE) fields ($E_z = E_y = H_x = 0$), where an O-BMS occupies the plane $z = 0$, surrounded by homogeneous medium with permittivity ϵ and permeability μ [Figs. 1(a) and 2(a)]. The O-BMS is characterized by its electric surface impedance $Z_{se}(y)$, magnetic surface admittance $Y_{sm}(y)$, and magneto-electric coupling coefficient $K_{em}(y)$. The wave impedance is $\eta = \sqrt{\mu/\epsilon}$, the wave number is $k = \omega\sqrt{\mu\epsilon}$, and the time-harmonic dependency is $e^{j\omega t}$. The fields below ($z < 0$) and above ($z > 0$) the metasurface are denoted as

$\{E_x^<(y, z), H_y^<(y, z), H_z^<(y, z)\}$ and $\{E_x^>(y, z), H_y^>(y, z), H_z^>(y, z)\}$, respectively.

The relation between the tangential fields on the bottom ($z \rightarrow 0^-$) and top ($z \rightarrow 0^+$) facets of the metasurface is given by the O-BMS sheet transition conditions (O-BSTCs) [22,23]

$$\begin{aligned} \frac{1}{2}(E_x^+ + E_x^-) &= -Z_{se}(H_y^+ - H_y^-) - K_{em}(E_x^+ - E_x^-), \\ \frac{1}{2}(H_y^+ + H_y^-) &= -Y_{sm}(E_x^+ - E_x^-) + K_{em}(H_y^+ - H_y^-), \end{aligned} \quad (1)$$

where we define $E_x^-(y) = E_x^<(y, z)|_{z \rightarrow 0^-}$, $E_x^+(y) = E_x^>(y, z)|_{z \rightarrow 0^+}$ (and analogously for H_y^\pm); the y dependency is omitted for brevity.

As discussed in [22], if the fields just below and above the metasurface *locally* conserve the real power $P_z(y)$, namely,

$$P_z^-(y) = \frac{1}{2} \Re\{E_x^- H_y^{-*}\} = \frac{1}{2} \Re\{E_x^+ H_y^{+*}\} = P_z^+(y), \quad (2)$$

for each y on the metasurface, then there exists a passive lossless solution ($\Re\{Z_{se}\} = \Re\{Y_{sm}\} = \Im\{K_{em}\} = 0$ [23]) to the O-BSTCs, given by

$$\begin{aligned} K_{em} &= \frac{1}{2} \frac{\Re\{E_x^+ H_y^{-*} - E_x^- H_y^{+*}\}}{\Re\{(E_x^+ - E_x^-)(H_y^+ - H_y^-)^*\}}, \\ Y_{sm} &= -j \left(\frac{1}{2} \Im\left\{ \frac{H_y^+ + H_y^-}{E_x^+ - E_x^-} \right\} - K_{em} \Im\left\{ \frac{H_y^+ - H_y^-}{E_x^+ - E_x^-} \right\} \right), \\ Z_{se} &= -j \left(\frac{1}{2} \Im\left\{ \frac{E_x^+ + E_x^-}{H_y^+ - H_y^-} \right\} + K_{em} \Im\left\{ \frac{E_x^+ - E_x^-}{H_y^+ - H_y^-} \right\} \right). \end{aligned} \quad (3)$$

Our first goal is to harness this theorem to design a passive lossless O-BMS that splits a normally incident plane wave to two equal-power plane waves propagating towards $\theta = \pm\theta_{\text{out}}$ [Fig. 1(a)]. According to the derivation in Eqs. (1)–(3), to achieve this goal we need to stipulate the fields below and above the metasurface such that (i) they obey Maxwell's equations in the respective regions, (ii) they satisfy local power conservation [Eq. (2)], and (iii) they coincide with the given incident and desirable transmitted fields in the far-field region.

To understand the challenge underlying these requirements, we examine the power profiles on the two facets of the metasurface. The desirable fields above the metasurface are a superposition of two plane waves with equal amplitudes E_{out} , namely,

$$\begin{aligned} E_x^>(y, z) &= E_{\text{out}} e^{-jkz \cos \theta_{\text{out}}} (e^{-jky \sin \theta_{\text{out}}} + e^{jky \sin \theta_{\text{out}}}), \\ H_y^>(y, z) &= \frac{E_{\text{out}}}{Z_{\text{out}}} e^{-jkz \cos \theta_{\text{out}}} (e^{-jky \sin \theta_{\text{out}}} + e^{jky \sin \theta_{\text{out}}}), \end{aligned} \quad (4)$$

where $Z_{\text{out}} = \eta / \cos \theta_{\text{out}}$ is the TE wave impedance. The real power profile just above the metasurface ($z \rightarrow 0^+$) is thus given by

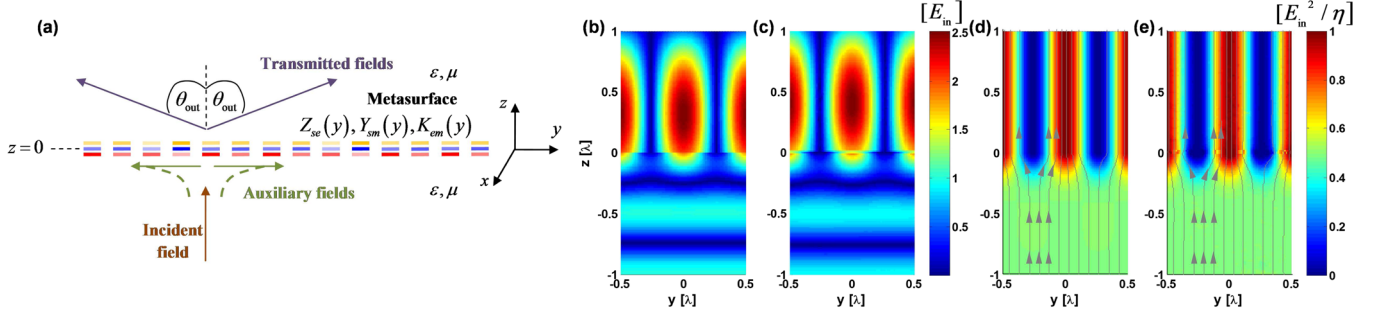


FIG. 1. O-BMS for reflectionless wide-angle beam splitting. (a) Physical configuration. (b) Analytically predicted [Eqs. (4) and (6)] and (c) simulated electric field distribution $|\Re\{E_x(y, z)\}|$. (d) Analytically predicted and (e) simulated z -directed real power $P_z(y, z) = \frac{1}{2}\Re\{E_x H_y^*\}$; gray streamlines indicate flow of real power from bottom to top.

$$P_z^+(y) = 4 \frac{|E_{\text{out}}|^2}{Z_{\text{out}}} \cos^2(ky \sin \theta_{\text{out}}), \quad (5)$$

spatially varying following a squared cosine. On the other hand, a simple plane wave normally incident upon the metasurface from below would form a uniform power profile on the bottom facet ($z \rightarrow 0^-$).

Therefore, to match the power profiles on the two facets of the metasurface, auxiliary fields are required. The idea is to introduce suitable evanescent modes to the region below the metasurface such that their interference with the incident field would redistribute the (otherwise uniform) real power on the bottom facet $P_z^-(y)$, leading to the desirable squared-cosine modulation matching $P_z^+(y)$. Being evanescent, these auxiliary fields would not affect the performance in the far field, as required.

One possible choice is to add surface waves propagating at opposite directions (towards $y \rightarrow \pm\infty$) on the bottom facet. With this choice, the fields below the metasurface would be

$$\begin{aligned} E_x^<(y, z) &= E_{\text{in}} e^{-jkz} + E_{\text{sw}} e^{\alpha_{\text{sw}} z} (e^{-2jk y \sin \theta_{\text{out}}} + e^{2jk y \sin \theta_{\text{out}}}), \\ H_y^<(y, z) &= \frac{E_{\text{in}}}{Z_{\text{in}}} e^{-jkz} + j \frac{\alpha_{\text{sw}} E_{\text{sw}}}{k\eta} e^{\alpha_{\text{sw}} z} (e^{-2jk y \sin \theta_{\text{out}}} + e^{2jk y \sin \theta_{\text{out}}}), \end{aligned} \quad (6)$$

where E_{in} is the (given) amplitude of the incident field, $Z_{\text{in}} = \eta / \cos \theta_{\text{in}}$ is the wave impedance ($\theta_{\text{in}} = 0$), E_{sw} is the amplitude of the surface waves, and $\alpha_{\text{sw}} = k\sqrt{4\sin^2 \theta_{\text{out}} - 1} \in \mathbb{R}$ is their decay constant (implying $\theta_{\text{out}} > 30^\circ$).

Assuming the field amplitudes are related via $E_{\text{sw}} = aE_{\text{in}}$, $a \in \mathbb{R}$, the real power on the bottom facet of the metasurface ($z \rightarrow 0^-$) will be given by

$$P_z^-(y) = \frac{|E_{\text{in}}|^2}{Z_{\text{in}}} [1 + 2a \cos(2ky \sin \theta_{\text{out}})]. \quad (7)$$

Comparing Eq. (5) with Eq. (7) indicates that local power conservation Eq. (2) may be achieved if we choose

$E_{\text{out}} = \frac{1}{\sqrt{2}} E_{\text{in}} e^{-j\xi_{\text{out}}} \sqrt{Z_{\text{out}}/Z_{\text{in}}}$ and $a = \frac{1}{2}$, where ξ_{out} is a possible phase shift.

This step finalizes the design procedure. Fixing the amplitudes as prescribed allows evaluation of the fields everywhere in space via Eq. (6) and Eq. (4), and in particular on the metasurface facets ($z \rightarrow 0^\pm$). As these fields satisfy Maxwell's equations and local power conservation, we may substitute them into Eq. (3) to assess the (passive lossless) O-BMS specifications that implement the required field transformation.

To verify our theory, we follow the outlined procedure and design an O-BMS that couples a normally incident plane wave to two equal-power plane waves propagating towards $\theta = \pm\theta_{\text{out}} = \pm 71.81^\circ$, incurring a phase shift of $\xi_{\text{out}} = 145^\circ$. The design is implemented in ANSYS HFSS following [21,22], based on three cascaded reactive sheets; the unit cell size is $\Delta y = \lambda/9.5$ [28].

One period of the metasurface $\Lambda = \lambda / \sin \theta_{\text{out}} = 10\Delta y$ was simulated with periodic boundary conditions, indicating that 49.5% of the incident power is coupled to each of the transmitted plane waves, while only 1% is specularly reflected. The analytically predicted field distributions [Fig. 1(b)] agree very well with the simulated ones [Fig. 1(c)], verifying that the normally incident wave front is transformed to two beams propagating towards $\pm 71.81^\circ$, yielding a typical interference pattern above the metasurface. The field distribution clearly shows the auxiliary surface waves formed at $z \rightarrow 0^-$, as stipulated in Eq. (6).

The role of the auxiliary fields is further highlighted in Figs. 1(d) and 1(e), where the real part of the z -directed Poynting vector $P_z(y, z)$ is depicted. The normally incident plane wave carries uniform power in the far field, but as the interference with the auxiliary surface wave becomes more significant near the O-BMS, the power is redistributed to match the power profile of the splitted beam above the aperture. This is emphasized by the gray lines following the power flow, indicating the diversion of power towards the peaks (red) and away from the valleys (blue) of the squared cosine of Eq. (5). We stress that the fields stipulated in Eqs. (4) and (5) form an *exact* solution to

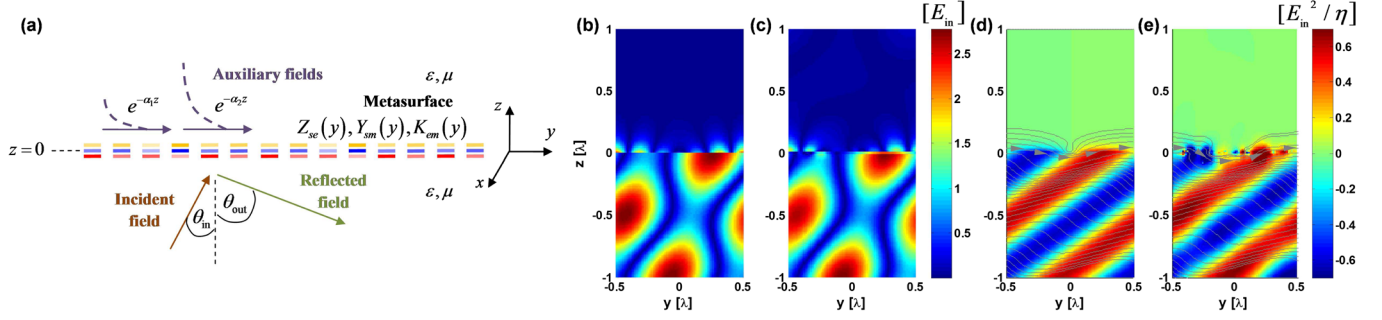


FIG. 2. O-BMS for perfect reflection. (a) Physical configuration. (b) Analytically predicted [Eqs. (8) and (10)] and (c) simulated electric field distribution $|\Re\{E_x(y, z)\}|$. (d) Analytically predicted and (e) simulated z -directed real power $P_z(y, z) = \frac{1}{2} \Re\{E_x H_y^*\}$; gray streamlines indicate flow of real power from left to right.

Maxwell's equations with the relevant boundary conditions, such that the passive lossless O-BMS design is strictly accurate.

The second functionality we consider is “perfect” engineered reflection [26]. In this case, we desire to fully couple a plane wave with an angle of incidence θ_{in} to a plane wave reflected towards θ_{out} [Fig. 2(a)]. The fields below the metasurface can be thus written as

$$\begin{aligned} E_x^<(y, z) &= E_{in} e^{-jkz \cos \theta_{in}} e^{-jky \sin \theta_{in}} \\ &\quad - E_{out} e^{jkz \cos \theta_{out}} e^{-jky \sin \theta_{out}}, \\ H_y^<(y, z) &= \frac{E_{in}}{Z_{in}} e^{-jkz \cos \theta_{in}} e^{-jky \sin \theta_{in}} \\ &\quad + \frac{E_{out}}{Z_{out}} e^{jkz \cos \theta_{out}} e^{-jky \sin \theta_{out}}, \end{aligned} \quad (8)$$

where E_{in} and E_{out} are the amplitudes of the incident and reflected plane waves, respectively. To guarantee *global* power conservation (integrated over the aperture), we set $E_{out} = E_{in} e^{-j\xi_{out}} \sqrt{Z_{out}/Z_{in}}$, where ξ_{out} is a possible phase shift. Hence, the real power on the bottom facet of the metasurface is

$$P_z^-(y) = \frac{|E_{in}|^2}{2Z_{in}} \left(\sqrt{\frac{Z_{in}}{Z_{out}}} - \sqrt{\frac{Z_{out}}{Z_{in}}} \right) \cos(ky \Delta_{sin} + \xi_{out}), \quad (9)$$

where $\Delta_{sin} = \sin \theta_{out} - \sin \theta_{in}$.

This power profile is even more intricate than the one examined before [Eq. (5)], as it changes signs along the metasurface plane: power is crossing the metasurface from bottom to top at one half of a period, whereas in the other half, power is crossing the metasurface from top to bottom. This means that to support such a field transformation with a passive lossless O-BMS, it is required to conceive a mechanism that draws the power from below at one half-period and pushes it back to the bottom half-space at the other half-period.

Naively trying to stipulate zero fields on the top facet would lead, in general, to lossy and active design

requirements [26], as it would violate local power conservation. However, using auxiliary evanescent modes above the metasurface we can match the desirable power profile of Eq. (9) without affecting the device functionality. The oscillating power profile is formed by interfering two surface waves, traveling on the top facet of the metasurface. As surface waves do not generally carry real power perpendicular to their propagation direction, we introduce a $\pi/2$ phase shift between them. Correspondingly, the fields above the O-BMS are defined as

$$\begin{aligned} E_x^>(y, z) &= E_{sw,1} e^{-\alpha_1 z} e^{-jk_{t,1} y} + j E_{sw,2} e^{-\alpha_2 z} e^{-jk_{t,2} y}, \\ H_y^>(y, z) &= -j \frac{\alpha_1 E_{sw,1}}{k\eta} e^{-\alpha_1 z} e^{-jk_{t,1} y} + \frac{\alpha_2 E_{sw,2}}{k\eta} e^{-\alpha_2 z} e^{-jk_{t,2} y}, \end{aligned} \quad (10)$$

where $E_{sw,n}$, $|k_{t,n}| > k$, and $\alpha_n = \sqrt{k_{t,n}^2 - k^2} > 0$ are the amplitude, transverse wave number, and decay coefficient of the n th surface wave, respectively. We define $E_{sw,2} = b e^{-j\xi_{out}} E_{sw,1}$ ($b \in \mathbb{R}$), yielding the following power profile on the top facet

$$P_z^+(y) = \frac{b |E_{sw,1}|^2}{2\eta} \frac{\alpha_2 - \alpha_1}{k} \cos[(k_{t,2} - k_{t,1})y + \xi_{out}]. \quad (11)$$

Comparing Eq. (11) with Eq. (9) reveals that local power conservation may be achieved by setting $k_{t,2} = k_{t,1} + k \Delta_{sin}$ and $b = (k\eta |E_{in}|^2) / [(\alpha_2 - \alpha_1) Z_{in} |E_{sw,1}|^2] [\sqrt{(Z_{in}/Z_{out})} - \sqrt{(Z_{out}/Z_{in})}]$; $k_{t,1}$ and $E_{sw,1}$ can be chosen at will, as long as $|k_{t,n}| > k$.

As for the beam-splitter application, once we achieve local power conservation the design procedure is completed. The stipulated fields in Eqs. (8) and (10) can be evaluated at $z \rightarrow 0^\pm$ and substituted into Eq. (3) to yield the O-BMS specifications.

To verify this scheme, we follow the procedure outlined in Eqs. (8)–(11) to design a perfect reflector which fully couples a plane wave incident from $\theta_{in} = 0$ to a plane wave

reflected towards $\theta_{\text{out}} = 71.81^\circ$, imposing a phase shift of $\xi_{\text{out}} = 90^\circ$; for simplicity, we choose $k_{r,1} = 2k$, $E_{\text{sw},1} = E_{\text{in}}$. One period of the O-BMS $\Lambda = \lambda/\Delta_{\text{sin}} = 10\Delta y$ is once more implemented in ANSYS HFSS using cascaded reactive sheets [21,22,28].

Good agreement is found between the analytically predicted and simulated fields [Figs. 2(b) and 2(c)], implying that 98.5% of the power is successfully coupled from the incident mode to the reflected one. The interference patterns of the incident and reflected fields below and the surface waves above the O-BMS are clearly observed. Figures 2(d) and 2(e) show that the auxiliary fields guarantee the continuity of P_z on the metasurface plane, shifting power upwards (red) and downwards (blue) alternately. The gray power-flow streamlines demonstrate that, indeed, the interference between the auxiliary surface waves forms the mechanism by which power can circulate between the bottom and top facets, establishing local power conservation.

To conclude, we have presented a paradigm for synthesis of O-BMSs for prescribed beam manipulation, without requiring active or lossy components, and without any compromise on device performance. Our approach makes use of auxiliary fields to facilitate the local power conservation required for achieving reactive designs; being evanescent, these fields do not interfere with the device functionality in the far field. We have demonstrated this concept by designing O-BMSs for reflectionless beam splitting and perfect reflection, functionalities that were considered impossible to implement accurately with passive lossless metasurfaces.

It is worth noting that although auxiliary fields were utilized in the past to establish realizable metasurface constituents, they were mainly used to satisfy *mathematical* conditions related to holography or Floquet-Bloch (FB) theory [11,20]. Contrarily, the auxiliary fields introduced herein serve a very clear *physical* purpose: they manipulate the flow of real power by harnessing precise interference effects. Furthermore, they are not bound to any specific form. While the fields stipulated to solve the beam-splitting problem are consistent with the general FB intuition, coinciding with the second-order FB modes, this is not the case for the perfect reflection O-BMS. Although the latter is also periodic, the auxiliary surface waves are *not* FB modes of the incident field. This observation emphasizes the dramatic conceptual difference with respect to previous reports, highlighting the extensive freedom designers have in stipulating auxiliary fields—even beyond the standard FB scheme [28].

Because of this vast freedom, it is difficult to estimate the limitations of the presented approach. The necessity to satisfy the local power conservation condition clearly poses some constraints on the achievable transformations. Nevertheless, as this rule applies to the power profile rather than the fields, and, as demonstrated, the former

can be extensively manipulated by introducing auxiliary fields, the range of applications could be far broader than *a priori* expected. Thus, this range should be assessed by continuous exploration of the concept for a variety of applications.

It should be stressed that the fields analytically stipulated using this approach are *exact* solutions to Maxwell's equations with the O-BSTCs, and no approximation is used in the process. Importantly, no external sources are required to excite the auxiliary fields: they are self-consistently generated by the currents induced on the metasurface due to the incident fields [28]. Albeit what might be inferred from [26], the designs are composed of standard, local, reciprocal, passive, and lossless meta-atoms [3,27]. Integrating this unorthodox approach into metasurface synthesis would allow accurate reactive solutions for many other challenging applications.

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- [1] C. L. Holloway, E. F. Kuester, J. A. Gordon, J. O'Hara, J. Booth, and D. R. Smith, An overview of the theory and applications of metasurfaces: The two-dimensional equivalents of metamaterials, *IEEE Antennas Propag. Mag.* **54**, 10 (2012).
- [2] S. A. Tretyakov, Metasurfaces for general transformations of electromagnetic fields, *Phil. Trans. R. Soc. A* **373**, 20140362 (2015).
- [3] K. Achouri, B. A. Khan, S. Gupta, G. Lavigne, M. A. Salem, and C. Caloz, Synthesis of electromagnetic metasurfaces: Principles and illustrations, *Euro. Phys. J. Appl. Metamaterials* **2**, 12 (2015).
- [4] N. M. Estakhri and A. Alù, Recent progress in gradient metasurfaces, *J. Opt. Soc. Am. B* **33**, A21 (2016).
- [5] A. Epstein and G. V. Eleftheriades, Huygens' metasurfaces via the equivalence principle: design and applications, *J. Opt. Soc. Am. B* **33**, A31 (2016).
- [6] N. Yu, P. Genevet, M. A. Kats, F. Aieta, J.-P. Tetienne, F. Capasso, and Z. Gaburro, Light propagation with phase discontinuities: generalized laws of reflection and refraction., *Science* **334**, 333 (2011).
- [7] M. Selvanayagam and G. V. Eleftheriades, Discontinuous electromagnetic fields using orthogonal electric and magnetic currents for wavefront manipulation, *Opt. Express* **21**, 14409 (2013).

- [8] F. Monticone, N. M. Estakhri, and A. Alù, Full Control of Nanoscale Optical Transmission with a Composite Metascreen, *Phys. Rev. Lett.* **110**, 203903 (2013).
- [9] C. Pfeiffer and A. Grbic, Metamaterial Huygens' Surfaces: Tailoring Wave Fronts with Reflectionless Sheets, *Phys. Rev. Lett.* **110**, 197401 (2013).
- [10] S. Maci, G. Minatti, M. Casaletti, and M. Bosiljevac, Metasurfing: Addressing waves on impenetrable metasurfaces, *IEEE Antennas Wireless Propag. Lett.* **10**, 1499 (2011).
- [11] G. Minatti, M. Faenzi, E. Martini, F. Caminita, P. De Vita, D. Gonzalez-Ovejero, M. Sabbadini, and S. Maci, Modulated metasurface antennas for space: Synthesis, analysis and realizations, *IEEE Trans. Antennas Propag.*, **63**, 1288 (2015).
- [12] F. Aieta, M. A. Kats, P. Genevet, and F. Capasso, Multi-wavelength achromatic metasurfaces by dispersive phase compensation, *Science* **347**, 1342 (2015).
- [13] C. Pfeiffer, C. Zhang, V. Ray, L. J. Guo, and A. Grbic, High Performance Bianisotropic Metasurfaces: Asymmetric Transmission of Light, *Phys. Rev. Lett.* **113**, 023902 (2014).
- [14] C. Pfeiffer and A. Grbic, Controlling Vector Bessel Beams with Metasurfaces, *Phys. Rev. Applied* **2**, 044012 (2014).
- [15] V. S. Asadchy, Y. Ra'di, J. Vehmas, and S. A. Tretyakov, Functional Metamirrors Using Bianisotropic Elements, *Phys. Rev. Lett.* **114**, 095503 (2015).
- [16] V. S. Asadchy, I. A. Faniayeu, Y. Ra'di, S. A. Khakhomov, I. V. Semchenko, and S. A. Tretyakov, Broadband reflectionless metasheets: Frequency-Selective Transmission and Perfect Absorption, *Phys. Rev. X* **5**, 031005 (2015).
- [17] A. Epstein, J. P. S. Wong, and G. V. Eleftheriades, Cavity-excited Huygens' metasurface antennas for near-unity aperture efficiency from arbitrarily large apertures, *Nat. Commun.* **7**, 10360 (2016).
- [18] M. Selvanayagam and G. V. Eleftheriades, Circuit modeling of Huygens surfaces, *IEEE Antennas Wireless Propag. Lett.*, **12**, 1642 (2013).
- [19] A. Epstein and G. V. Eleftheriades, Passive lossless Huygens metasurfaces for conversion of arbitrary source field to directive radiation, *IEEE Trans. Antennas Propag.*, **62**, 5680 (2014).
- [20] A. Epstein and G. V. Eleftheriades, Floquet-Bloch analysis of refracting Huygens metasurfaces, *Phys. Rev. B* **90**, 235127 (2014).
- [21] J. P. S. Wong, A. Epstein, and G. V. Eleftheriades, Reflectionless wide-angle refracting metasurfaces, *IEEE Antennas Wireless Propag. Lett.*, **15**, 1293 (2016).
- [22] A. Epstein and G. V. Eleftheriades, Arbitrary power-conserving field transformations with passive lossless omega-type bianisotropic metasurfaces, *IEEE Trans. Antennas Propag.*, **64**, 3880 (2016).
- [23] Y. Ra'di and S. A. Tretyakov, Balanced and optimal bianisotropic particles: Maximizing power extracted from electromagnetic fields, *New J. Phys.* **15**, 053008 (2013).
- [24] Y. Ra'di, V. S. Asadchy, and S. A. Tretyakov, Tailoring reflections from thin composite metamirrors, *IEEE Trans. Antennas Propag.*, **62**, 3749 (2014).
- [25] N. M. Estakhri and A. Alù, Wave-Front Transformation with Gradient Metasurfaces, *Phys. Rev. X* **6**, 041008 (2016).
- [26] V. S. Asadchy, M. Albooyeh, S. N. Tsvetkova, A. Díaz-Rubio, Y. Ra'di, and S. A. Tretyakov, Perfect control of reflection and refraction using spatially dispersive metasurfaces, *Phys. Rev. B* **94**, 075142 (2016).
- [27] C. Pfeiffer and A. Grbic, Bianisotropic Metasurfaces for Optimal Polarization Control: Analysis and Synthesis, *Phys. Rev. Applied* **2**, 044011 (2014).
- [28] See Supplemental Material at <http://link.aps.org/supplemental/10.1103/PhysRevLett.117.256103> for details regarding full-wave simulations of finite-size O-BMSs excited by a Gaussian beam (demonstrating the self-evolution of the auxiliary fields), metasurface implementation in ANSYS HFSS, and a discussion in the relations between auxiliary fields and FB modes, and their respective roles. The Supplemental Material includes Refs. [29,30].
- [29] E. F. Kuester, M. A. Mohamed, M. Piket-May, and C. L. Holloway, Averaged transition conditions for electromagnetic fields at a metafilm, *IEEE Trans. Antennas Propag.* **51**, 2641 (2003).
- [30] C. Pfeiffer and A. Grbic, Planar lens antennas of subwavelength thickness: Collimating leaky waves with metasurfaces, *IEEE Trans. Antennas Propag.* **63**, 3248 (2015).